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By: Annie Wong
Annie Wong

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Bergh et al.

Serial No.: 09/801,389

Group Art 1764
Unit:

Filed: 3/7/01

For: PARALLEL FLOW REACTOR
HAVING VARIABLE
COMPOSITIONS

Examiner: Unknown

Assistant Commissioner for Patents and Trademarks
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Applicant requests that the references cited herein be considered in connection with the examination of this application and listed on the front of any patent that issues. The references are listed on the attached modified PTO-1449 form. Copies of the references were previously cited and submitted to the Patent and Trademark Office in connection with the parent application, U.S. Serial No. 09/801,390. As such, under 37 CFR section 1.98(d), no further copies are provided.

Applicant believes that no fee is required for submission of this statement. If a fee is required, the Commissioner is authorized to deduct such fee from Deposit Account No. 50-0496.

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INFORMATION DISCLOSURE CITATION  PTO-1449		ATTORNEY'S DOCKET NO.:		APPLICATION NO.:	
		2000-022DIV1		09/801,389	
		APPLICANT: Bergh et al.		FILING DATE: 3/7/2001	
US PATENT DOCUMENTS					
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS
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EXAMINER:	DATE CONSIDERED:		

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